



Practitioner's Docket No.: 782_208

2821
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Yukihiisa TAKEUCHI, Tsutomu NANATAKI, Iwao
OHWADA and Tomoya HORIUCHI

Ser. No.: 10/027,232

Art Unit: 2821

Filed: December 20, 2001

Examiner: Minh D. A

Confirmation No.: 9132

For: ELECTRON-EMITTING DEVICE AND FIELD EMISSION DISPLAY USING THE
SAME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Janet M. Stevens
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INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is
hereby directed to the references listed on the attached Form PTO-1449.

**The PTO is NOT authorized to charge the undersigned
representative's deposit account for any fees associated with this IDS.**

December 6, 2004

Date

Respectfully submitted,

Stephen P. Burr
Reg. No. 32,970

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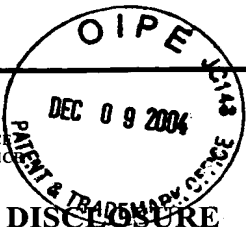
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Form PTO-1449

US DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)



Complete if Known

Application Number	10/027,232
Filing Date	December 20, 2001
First Named Inventor	Yukihisa TAKEUCHI
Art Unit	2821
Examiner Name	A, MINH D
Confirmation No.	9132
Attorney Docket No.	782_208

Sheet

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of


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U.S. PATENT DOCUMENTS

Exam. Initial		Document Number	Date	Name	Our Docket No.	Class	Sub Class	Filing Date
	BA	5,874,802	02-23-1999	Choi et al				
	BC	5,280,221	01-18-1994	Okamoto et al.				
	BD	5,747,926	05-05-1998	Nakamoto et al.				
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	BF	6,479,924	11-12-2002	Yoo				
	BG	6,313,815	11-06-2001	Takeda et al.				
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	BN	6,359,383	03-19-2002	Chuang et al.				
	BO	6,274,881	08-14-2001	Akiyama et al.				
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	BV	5,726,524	03-10-1998	Debe				

Examiner:		Date Considered:	
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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			Application Number	10/027,232		
			Filing Date	December 20, 2001		
			First Named Inventor	Yukihisa TAKEUCHI		
			Art Unit	2821		
			Examiner Name	A, MINH D		
			Confirmation No.	9132		
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U.S. RELATED COPENDING APPLICATIONS

Exam. Initial		Application No.	Filing Date	Publication No.	Publication Date	Inventor Name	Docket No.	Class	Sub Class
	BW	10/374,955	02-25-2003	2004/0100200	05-27-2004	Takeuchi et al.	789_105		
	BX	10/459,110	06-11-2003	2004/0104684	06-03-2004	Takeuchi et al.	789_109 CIP		
	BY	10/459,416	06-11-2003	2004/0104690	06-03-2004	Takeuchi et al.	789_110 CIP		
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	CB	10/671,763	09-26-2003	2004/0061431	04-01-2004	Takeuchi et al.	789_117		
	CC	10/699,186	10-31-2003	2004/0090398	05-13-2004	Takeuchi et al.	789_119		
	CD	10/719,596	11-21-2003	2004/0113561	06-17-2004	Takeuchi et al.	789_121		
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	CP	10/951,832	09/28/2004			Takeuchi et al.	789_136		
	CQ	10/952,524	09/28/2004			Takeuchi et al.	789_135		

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Form PTO-1449				<i>Complete if Known</i>	
US DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				Application Number 10/027,232	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Filing Date December 20, 2001	
				First Named Inventor Yukihiisa TAKEUCHI	
				Art Unit 2821	
				Examiner Name A, MINH D	
				Confirmation No. 9132	
Sheet 3 of 4	Attorney Docket No. 782_208				

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	DI	08-111166 A1	04-30-1996	JP				

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				Confirmation No.	9132
Sheet	4	of	4	Attorney Docket No.	782_208

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	DK	Puchkarev, Victor F. and Mesyats, Gennady A., "On the Mechanism of Emission from the Ferroelectric Ceramic Cathode," Journal of Applied Physics, Vol. 78, No. 9, 1 November 1995, pp. 5633-5637.
	DL	Riege, H., "Electron Emission from Ferroelectrics - a Review," Nucl. Instr. and Meth. A340, 1994, pp. 80-89.
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